

08-17-2000

Docket No.: NPO0005

FORM PTO-1565 (Modified)
(Rev. 6-93)
OMB No. 0651-0011 (exp 4/94)
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P08A/REV02

U.S. DEPARTMENT OF COMMERCE
Patent and Trademark Office



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To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies): MRO 84.00
Keiji Ishibashi
Additional names(s) of conveying party(ies) Yes No

2. Name and address of receiving party(ies):
Name: ANELVA CORPORATION
Address: 5-8-1, Yotsuya, Fuchu-shi
City: Tokyo State/Prov.: _____
Country: JAPAN ZIP: _____
Additional name(s) & address(es) Yes No
**see attached*

Jc784 U.S. PTO
09/633002
08/04/00

3. Nature of conveyance:
 Assignment Merger
 Security Agreement Change of Name
 Other _____
Execution Date: July 26, 2000

4. Application number(s) or registration numbers(s):
If this document is being filed together with a new application, the execution date of the application is: July 26, 2000
Patent Application No. Unknown Filing date August 4, 2000
B. Patent No.(s) 09/633002
Additional numbers Yes No

5. Name and address of party to whom correspondence concerning document should be mailed:
Name: Anthony Niewyk
Registration No. 24,871
Address: Baker & Daniels
04/15/2000 0000019 09/633002
02 FC:581 40.00
City: Fort Wayne State/Prov.: IN
Country: USA ZIP: 46802

6. Total number of applications and patents involved: 1
7. Total fee (37 CFR 3.41):.....\$ 40.00
 Enclosed - Any excess or insufficiency should be credited or debited to deposit account
 Authorized to be charged to deposit account
8. Deposit account number:
02-0385

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9. Statement and signature.
To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.
Anthony Niewyk August 4, 2000
Name of Person Signing Signature Date
Total number of pages including cover sheet, attachments, and 5

2. Name and address of receiving party(ies):

Name: JAPAN SCIENCE AND TECHNOLOGY CORPORATION

Address: 1-8, Hon-cho 4-chome, Kawaguchi-shi

City: Saitama

Country: JAPAN

ASSIGNMENT

WHEREAS, I, Keiji Ishibashi, residing at 1181-103, Kotta, Tama-shi, Tokyo, Japan, am the inventor of certain improvements in:

A HOT ELEMENT CVD APPARAUS AND A METHOD FOR REMOVING A DEPOSITED FILM

as described and claimed in an application for Letters Patent of The United States of America thereon, said application having been executed by us on even date herewith; and

WHEREAS, ANELVA CORPORATION, a corporation organized and existing under the laws of the Country of Japan, having its principal place of business at 5-8-1, Yotsuya, Fuchu-shi, Tokyo, Japan and JAPAN SCIENCE AND TECHNOLOGY CORPORATION, a corporation organized and existing under the laws of the Country of Japan, having its principal place of business at 1-8, Hon-cho 4-chome, Kawaguchi-shi, Saitama, Japan, is to acquire my entire right, title and interest in and to said invention and said application for Letters Patent;

NOW, THEREFORE, in consideration of the sum of ONE DOLLAR (\$1.00) to me in hand paid, and for other good and valuable consideration, the receipt and sufficiency whereof is hereby acknowledged, I, Keiji Ishibashi, do hereby assign, sell, transfer and set over unto said ANELVA CORPORATION and JAPAN SCIENCE AND TECHNOLOGY CORPORATION, its successors and assigns, my full, entire and exclusive right, title and interest, for the territory of the United States of America and for all foreign countries, in and to said invention, as described in the application identified above, and in and to said application and any divisions or continuations or continuations-in-part thereof or substitutes therefor which may be filed, and in and to any patents or reissues, renewals or extensions thereof which may be granted on said application or for said invention, and in and to any patent application which may be filed on said invention in countries foreign to the United States of America and any patents granted thereon; said invention, applications, and patents to be held and enjoyed by said ANELVA CORPORATION and JAPAN SCIENCE AND TECHNOLOGY CORPORATION, and its successors or assigns, to the full end of the term

or terms for which said patents may be granted, as fully and entirely as the same would have been held by us had this assignment not been made.

We hereby authorize and request the Patent and Trademark Office officials in the United States of America and the Patent Office officials of any and all foreign countries to issue any and all of said patents, when granted to said ANELVA CORPORATION and JAPAN SCIENCE AND TECHNOLOGY CORPORATION, as the assignees of my entire right, title and interest in and to the same for the sole use and enjoyment of said ANELVA CORPORATION and JAPAN SCIENCE AND TECHNOLOGY CORPORATION, its successors and assigns.

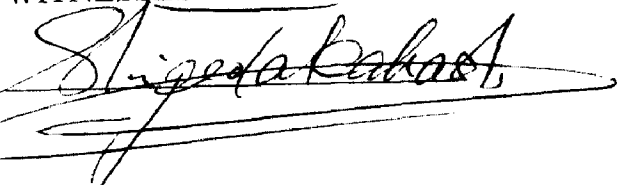
Further, I agree to execute all papers and to give such lawful testimony and to perform such other lawful acts as said ANELVA CORPORATION and JAPAN SCIENCE AND TECHNOLOGY CORPORATION, its successors and assigns may require to enable it or them to procure a Letters Patent on said invention or reissues or extensions thereof in the United States of America and/or in any foreign country, and/or to hold, enforce or convey said Letters Patent, reissues or extensions.

Executed this 24th day of July, 2000.



Keiji Ishibashi

WITNESSES:



Shigeo Takahashi

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